

PATENT ASSIGNMENT COVER SHEET

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Stylesheet Version v1.2

EPAS ID: PAT3858283

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
TAKASHI INOUE	04/18/2016
RECEIVING PARTY DATA	
Name:	NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL SCIENCE AND TECHNOLOGY
Street Address:	3-1, KASUMIGASEKI 1-CHOME
Internal Address:	CHIYODA-KU
City:	TOKYO
State/Country:	JAPAN
Postal Code:	100-8921
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	15034282
CORRESPONDENCE DATA	
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<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
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Address Line 4:	NEW HAVEN, COLORADO 06509-1950
ATTORNEY DOCKET NUMBER:	27231-56A
NAME OF SUBMITTER:	LINDA M. FREED
SIGNATURE:	/Linda M. Freed/
DATE SIGNED:	05/04/2016
Total Attachments: 2	
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ASSIGNMENT

WHEREAS, I/we,

Takashi Inoue, residing at Ibaraki, Japan;

having made an invention entitled RECEIVED SIGNAL PROCESSING DEVICE,
COMMUNICATION SYSTEM, AND RECEIVED SIGNAL PROCESSING METHOD,

Attorney Docket No. 27231- , an application for which a patent of The United States of
America is being executed concurrently herewith; or

I/we hereby authorize and request our attorney, John L. Cordani of Carmody
Torrance Sandak & Hennessey LLP, 195 Church Street, P.O. Box 1950, New Haven , CT
06509-1950 to insert the filing date and application number of said application when
known in the spaces provided below:

Filing Date: May 4, 2016
U.S. Serial Application No.: 15/034,282

NOW, THEREFORE, for good and valuable consideration, receipt of which is
acknowledged, I/we have agreed to assign and transfer and do hereby assign and transfer
unto **NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL SCIENCE AND
TECHNOLOGY**, having an office and place of business at 3-1, Kasumigaseki 1-chome,
Chiyoda-ku, Tokyo 100-8921 Japan, its successors and assigns, the entire right, title and
interest in and to the said invention and application, and in and to any divisional,
continuation or continuation-in-part, of said application, and in and to any and all patents
and reissues and extensions thereof, of The United States of America, which have been or
may be granted on any of the foregoing to be held and enjoyed as fully and exclusively as
they would have been by me/us had this assignment and transfer not been made;

I/We do further agree for myself/ourselves and for my/our heirs, executors and administrators to execute and deliver without further consideration any further applications, assignments and documents, and to perform such other acts as I/we lawfully may, that may be deemed necessary by the said **NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL SCIENCE AND TECHNOLOGY**, its successors, assigns, and nominees, fully to secure their interest as aforesaid and to obtain or maintain patents in any and all countries;

And I/we do hereby authorize and request the Commissioner of Patents to issue any and all patents which may be granted upon any of the said applications, to the said **NATIONAL INSTITUTE OF ADVANCED INDUSTRIAL SCIENCE AND TECHNOLOGY** as the assignee of the entire interest therein.

IN TESTIMONY WHEREOF, I/we have hereunto signed my/our name(s) on the date indicated hereinafter.

Takashi Inoue
NAME: Takashi Inoue

April 18, 2016
Date

SIGNED IN THE PRESENCE OF WITNESSES:

(1) Satoshi Suda
Print Name:

Date: April 18, 2016

(2) KIYO ISHII
Print Name:

Date: April 18, 2016